

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Sherman
Appl. No.	:	10/683,727
Filed	:	October 10, 2003
For	:	SEQUENTIAL CHEMICAL VAPOR DEPOSITION
Examiner	:	Kelly M. Stouffer
Group Art Unit	:	1762

AMENDMENT AND RESPONSE TO OFFICE ACTION**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted in response to the Office Action mailed on October 31, 2006. Applicant respectfully requests consideration of the subsequent remarks.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 4 of this paper.